

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 3788
Shinji MAEKAWA et al.)
Application No. 10/575,492) Examiner: Stanetta D. Isaac
Filed: April 12, 2006) Group Art Unit: 2812
For: METHOD FOR FORMING WIRING, METHOD)
FOR MANUFACTURING THIN FILM)
TRANSISTOR AND DROPLET DISCHARGING)
METHOD)

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed March 10, 2009, please amend the above-captioned application, as follows:

Amendments to the Claims are reflected in the listing of claims in the paper.

Remarks follow the amendment section of this paper.